

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	) Group Art Unit: 2621
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<b>Mototsugu Abe</b>	) Examiner: <b>Jamie Jo Atala</b>
	)
Application No. <b>09/840939</b>	) Confirmation No.: <b>5606</b>
	)
Filed: <b>April 24, 2001</b>	)
	)
For: APPARATUS AND METHOD FOR	)
PROCESSING SIGNALS	)

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**INFORMATION DISCLOSURE STATEMENT**

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants requests that citation and examination of the references identified on the attached PTO-SB08A form, in accordance with 37 C.F.R. § 1.98, be made during the course of examination of the above-referenced application for United States Letters Patent. References JP '783, '841, '436, '722, '827, '322, '933 and '717 were cited in a Japanese Office Action dated October 7, 2008 issued in connection with counterpart Japanese Patent Application No. 2006-313645. References JP '591 and '993 were cited in a Japanese Office Action dated December 25, 2008 issued in connection with counterpart Japanese Patent Application No. 2006-313645.

Copies of the foreign references, an English language abstract for JP '993, and a machine translations for JP '783, '841, '436, '722, '827, '322, '933, '717 and '591 are attached as are copies of the Japanese office actions.

Respectfully submitted,

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